



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: ZHU et al.

Attorney Docket No.:
LAM1P147/P0675

Application No.: 09/782,185

Examiner: CHEN, Kin-Chan

Filed: February 12, 2001

Group: 1765

Title: UNIQUE PROCESS CHEMISTRY FOR
ETCHING ORGANIC LOW-K MATERIALS

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the
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Signed: Sue Funchess
Sue Funchess

INFORMATION DISCLOSURE STATEMENT 37 CFR §§ 1.56 AND 1.97(b)

Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

The references listed in the attached PTO Form 1449, copies of which are attached, may be material to the patentability of the above-identified patent application. Each item of information contained herein was first cited in an International Search Report in a counterpart foreign application no more than three months prior to the filing of this Information Disclosure Statement. Applicants submit these references in compliance with their duty of disclosure pursuant to 37 CFR §§ 1.56 and 1.97, and request that the Examiner make these references of official record in this application.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that these references indeed constitute prior art.

Applicants believe that no fees are due in connection with the filing of this Information Disclosure Statement. However, if it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 50-0388 (Order No. LAM1P147/P0675).

Respectfully submitted,

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